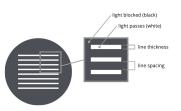


PTST050450P | DATASHEET

Stripes pattern, Photolitography



Opto Engineering® supplies a comprehensive range of projection patterns compatible with our LED illuminators.

PT projection patterns can be either laser-engraved, with 50 μ m geometrical accuracy, or photolitography-engraved for more demanding applications (2 µm accuracy).

SPECIFICATIONS

Туре	Stripes		
Process		Photolitography	
Substrate		Soda lime glass	
Coating		Chrome on glass	
Line spacing	(mm)	0.45	
Line thickness	(mm)	0.05	
Dot size	(mm x mm)	-	
Geometrical accuracy	(µm)	2	
Edge sharpness	(µm)	1.4	

Circular aperture (LTPR)

Active Area	(mm)	11
Number of lines		22
Max line length	(mm)	11

Square aperture (LTPRSM)

Active Area	(mm)	8 x 8
Number of lines		16
Max line length	(mm)	8

Mechanical specifications

	A second s		
Diameter	(mm)	21	
Thickness	(mm)	1.6	

COMPATIBLE PRODUCTS

Full list of compatible products available here.

OPTICS	LIGHTING	CAMERAS	SOFTWARE	ACCESSORIES

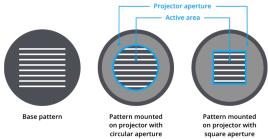
A wide selection of innovative machine vision components.

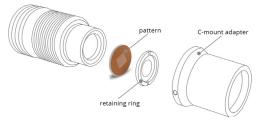
All product specifications and data are subject to change without notice to improve reliability, functionality, design or other. Photos and pictures are for illustration purposes only. Data are reported by design, actual lens performance may vary due to manufacturing tolerances.

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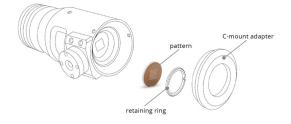
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PTPR AND ACTIVE AREA





Pattern projector with circular aperture disassembled.



Pattern projector with square aperture disassembled.